

# PARAMOUNT® SERIES 400 KHZ, 2 MHZ, 13 MHZ, 27 MHZ, 40 MHZ, 60 MHZ

DIGITALLY CONTROLLED RF POWER SUPPLIES FROM 400 KHZ TO 60 MHZ, AND POWER FROM 1.5 TO 8 KW, WITH FREQUENCY TUNING, PULSING, AND PULSE SYNCHRONIZATION

With full digital control and dynamic response to plasma changes, the Paramount® platform keeps you at the leading edge of process innovation.

# Benefits

- Enhanced plasma stability and process repeatability
- > Precise RF control
- Fast response to plasma changes
- Flexibility and adaptability for advancing manufacturing technologies

# **Features**

- > Full digital control
- Pulsing and pulse synchronization
- > Frequency tuning
- Real-time power and impedance measurement
- > Tightly regulated output power
- Models ranging from 400 kHz to 60 MHz and from 1.5 to 8 kW
- > Set points as low as 5 W
- > Arc management
- > Phase synchronization (CEX)

# Semiconductor Applications

- > PECVD
- > Dielectric and conductor etch
- > Sputtering

As manufacturing technologies evolve and rapid plasma transitions become the norm, the highly adaptable Paramount platform facilitates advanced process development. It combines accurate, repeatable power delivery with an inherently flexible digital architecture, wide output coverage, and a comprehensive feature set.

#### **DIGITAL ARCHITECTURE**

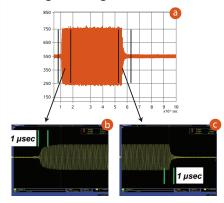
The Paramount platform's digital architecture allows extremely precise process measurement and control, as well as the adaptability to keep pace with increasing manufacturing demands. Advanced functions are easily integrated—without the lead times and integration issues associated with products requiring hardware changes.

#### WIDE POWER AND FREQUENCY COVERAGE

With power set points from 5 to 8000 W and frequencies from 400 kHz to 60 MHz, the Paramount series enables you to stay within a familiar platform as your RF needs change. Process upgrades and new process development are more efficient, with reduced integration issues and no "new-product" learning curves.

## **PULSING**

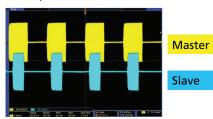
Reduced charge buildup, arcing, and feature distortion during etching



Example of pulsed RF waveform into a 50  $\Omega$  resistive load. (a) 10 kHz, 50% duty cycle (50  $\mu$ sec) waveform; (b) Close-up of the pulse's rising edge; (c) Close-up of the falling edge

### **PULSE SYNCHRONIZATION**

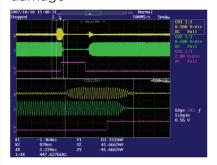
Synchronized pulses for multiple Paramount® units



Synchronized pulsing with timing offset and different pulse ontimes

#### **ARC MANAGEMENT**

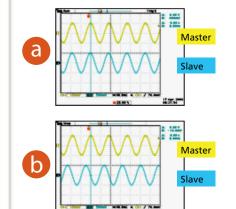
Reduced particle contamination, feature distortion, and equipment damage



Sudden change in reflected power indicating an arc; Rapid output power shutdown. All arc management parameters are user-selectable.

# PHASE SYNCHRONIZATION (CEX)

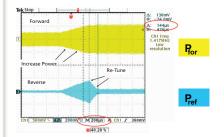
Synchronized output waveforms of connected Paramount® units



(a) 0° phase offset; (b) 90° offset. Phase offset is user-adjustable, 0 to 359°.

#### **FREQUENCY TUNING**

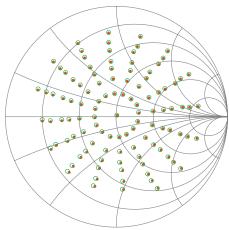
Fast tuning and repeatable power delivery during short process steps



Above, reflected power is minimized ~150 µsec after plasma power set point change.

#### ADVANCED POWER AND IMPEDANCE MEASUREMENT

Paramount RF power supplies measure plasma characteristics in real time and detect changes with extreme sensitivity. This enables high-accuracy power output and repeatable performance.



Paramount® Power and Impedance Measurement Rivals the Accuracy of a Network Analyzer.

| GENERAL<br>SPECIFICATIONS <sup>1</sup> | PARAMOUNT® MF   |   | PARAMOUNT®<br>HF   | PARAMOUNT®<br>VHF                                    |
|--|---|---|--|--|
| RF Power                               | 2.0 kW  | 5.0 kW  | 1.5 kW   | 3.0 kW   |
|  | 3.0 kW  |   | 3.0 kW   | 6.0 kW   |
|  | 5.0 kW  |   | 6.0 kW   | 7.0 kW   |
|  | 8.0 kW  |   |  |  |
| Frequencies                            | 400 kHz   | 2 MHz   | 13.56 MHz  | 27 MHz   |
|  | Frequency<br>tuning ±10%                                | Frequency<br>tuning ±10%                                | Frequency tuning ±5%   | 40 MHz   |
|  |   |   |  | 60 MHz   |
|  |   |   |  | Frequency tuning ±5%                                 |
| Typical Tune Time                      | < 100 ms  | < 100 ms  | < 10 ms  | < 10 ms  |
| Power Accuracy into 50 $\Omega$        | ±2 W or ±1%<br>of set point,<br>whichever<br>is greater | ±1 W or ±1%<br>of set point,<br>whichever is<br>greater | ±1 W or ±1% of set<br>point, whichever is<br>greater<br>Into 3:1 VSWR: ±1<br>W or ±2% of set<br>point, whichever is<br>greater | ±1 W or ±1% of set<br>point, whichever<br>is greater |
| Pulsing Frequency<br>Range             | 10 Hz to 2<br>kHz                                       | 10 Hz to 10<br>kHz                                      | 10 Hz to 100 kHz   | 10 Hz to 25 kHz                                      |
| Available Serial Interfaces            | RS-232, Ethernet, DeviceNet®, Profibus, EtherCAT®       |   |  |  |

<sup>1</sup> Electrical specifications vary by model number. Please contact an AE representative for more information.

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